



Development and Application of High Sensitivity Instrumentation

Guest Editor:

Dr. Graziella Scandurra

Department of Engineering,
University of Messina, 98166
Messina, Italy

Deadline for manuscript
submissions:

closed (20 November 2022)

Message from the Guest Editor

The development of highly sensitive instruments is a crucial issue in various fields. First of all, it is certainly fundamental in the fields of devices and materials characterization, DC charge transport investigations, high-temperature superconductor characterizations, and precise thermoelectric power measurements. Over time, highly sensitive instrumentation has also gained importance in more modern applications, such as sensors, biomedical applications, environmental monitoring, and sport. The purpose of this Special Issue is to collect contributions covering the state of the art and future prospects in this field. Papers focused on the applicative aspects of the instrumentation and on the circuit design are welcome.





an Open Access Journal by MDPI

Editor-in-Chief

Prof. Dr. Giulio Nicola Cerullo
Dipartimento di Fisica,
Politecnico di Milano, Piazza L.
da Vinci 32, 20133 Milano, Italy

Message from the Editor-in-Chief

As the world of science becomes ever more specialized, researchers may lose themselves in the deep forest of the ever increasing number of subfields being created. This open access journal Applied Sciences has been started to link these subfields, so researchers can cut through the forest and see the surrounding, or quite distant fields and subfields to help develop his/her own research even further with the aid of this multi-dimensional network.

Author Benefits

Open Access: free for readers, with article processing charges (APC) paid by authors or their institutions.

High Visibility: indexed within Scopus, SCIE (Web of Science), Inspec, CAPlus / SciFinder, and other databases.

Journal Rank: JCR - Q1 (Engineering, Multidisciplinary) / CiteScore - Q1 (General Engineering)

Contact Us

Applied Sciences Editorial Office
MDPI, Grosspeteranlage 5
4052 Basel, Switzerland

Tel: +41 61 683 77 34
www.mdpi.com

mdpi.com/journal/applsci
applsci@mdpi.com
[X@Applsci](#)